

ABSTRACT
COMPOSITION, METHOD FOR CLEANING ADHESIVE POLYMER,
METHOD FOR PRODUCING DEVICE WAFER, AND
METHOD FOR REGENERATING SUPPORT WAFER

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Provided is a composition having high affinity for the surface of an adhesive, and excellent long-term storage stability. This composition comprises: a quaternary alkylammonium fluoride or a hydrate of a quaternary alkylammonium fluoride; and an aprotic solvent, wherein the aprotic solvent includes (A) an N-substituted amide compound having 4 or more carbon
10 atoms and not containing active hydrogen on a nitrogen atom, and (B) an ether compound.

Figure 2